

Publikationen

(2018): Model based error separation of power spectral density artefacts in wavefront measurement. In: SPIE Optical Engineering + Applications Conference on Interferometry XIX, San Diego, CA, USA.

(2018): Model based error separation of power spectral density artefacts in wavefront measurement. In: Proceedings of SPIE 10749 (SPIE Optical Engineering + Applications Conference on Interferometry XIX [August 19-23, 2018; San Diego, CA, USA]). DOI: 10.1117/12.2321106.

(2018): Tilted wave interferometry for testing large surfaces. In: Proceedings of SPIE 10829 (Fifth European Seminar on Precision Optics Manufacturing [April 10-11, 2018; Teisnach]). DOI: 10.1117/12.2318573.